

INTERNATIONAL
GEMOLOGICAL
INSTITUTE

ELECTRONIC COPY

LABORATORY GROWN DIAMOND REPORT

January 10, 2026

IGI Report Number

LG764667885

Description

LABORATORY GROWN DIAMOND

Shape and Cutting Style

ROUND BRILLIANT

Measurements

6.77 - 6.80 X 4.24 MM

GRADING RESULTS

Carat Weight

1.21 CARAT

Color Grade

E

Clarity Grade

VS 1

Cut Grade

IDEAL

ADDITIONAL GRADING INFORMATION

Polish

EXCELLENT


Symmetry

EXCELLENT

Fluorescence

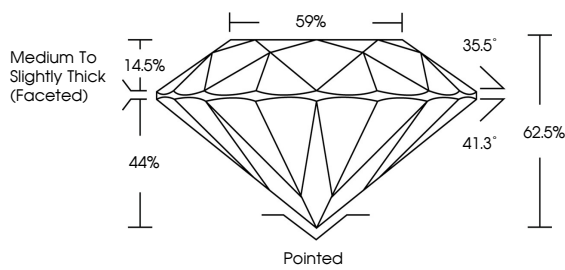
NONE

Inscription(s)

 LG764667885

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa

PROPORTIONS



Medium To Slightly Thick (Faceted)

59%

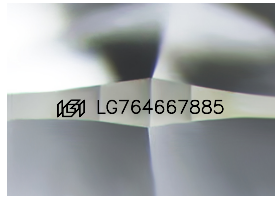
35.5°

41.3°

62.5%

44%

Pointed



Sample Image Used

COLOR

D

E

F

G

H

I

J

Faint

Very Light

Light

CLARITY

FL

IF

VS¹⁻²

VS¹⁻²

SI¹⁻²

I¹⁻³

Flawless



Internally Flawless

Very Very Slightly Included

Very Slightly Included

Slightly Included


Included



© IGI 2020, International Gemological Institute

FD - 10 20

LABORATORY GROWN DIAMOND REPORT



January 10, 2026

IGI Report Number

LG764667885

Description

LABORATORY GROWN DIAMOND

Shape and Cutting Style

ROUND BRILLIANT

Measurements

6.77 - 6.80 X 4.24 MM

GRADING RESULTS

Carat Weight

1.21 CARAT

Color Grade

E

Clarity Grade

VS 1

Cut Grade

IDEAL

ADDITIONAL GRADING INFORMATION

Polish

EXCELLENT


Symmetry

EXCELLENT


Fluorescence

NONE

Inscription(s)

 LG764667885

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa



IGI

January 10, 2026

IGI Report No LG764667885

ROUND BRILLIANT

6.77 - 6.80 X 4.24 MM

Carat Weight

1.21 CARAT

Color Grade

E

Clarity Grade

VS 1

Cut Grade

IDEAL

Depth

62.5%

Table

59%

Grade

Medium To Slightly Thick (Faceted)

Culet

Pointed

Polish

EXCELLENT


Symmetry

EXCELLENT

Fluorescence

NONE

Inscription(s)

 LG764667885

Comments: The Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa